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<b>SERIAL NUMBER</b> 09/811,401	<b>FILING DATE</b> 03/20/2001 <b>RULE</b>	<b>CLASS</b> <del>438</del> 257	<b>GROUP ART UNIT</b> <del>2817</del> 2827	<b>ATTORNEY DOCKET NO.</b> 500.39919X00
<b>APPLICANTS</b> Yoshihide Yamaguchi, Fujisawa, JAPAN; Hiroyuki Tenmei, Yokohama, JAPAN; Kosuke Inoue, Fujisawa, JAPAN; Noriyuki Oroku, Yokohama, JAPAN; Hiroshi Hozoji, Yokohama, JAPAN; Shigeharu Tsunoda, Fujisawa, JAPAN; Naoya Kanda, Fujisawa, JAPAN; Madoka Minagawa, Ebina, JAPAN; Ichiro Anjo, Koganei, JAPAN; Asao Nishimura, Kokubuji, JAPAN; Kenji Ujile, Higashimurayama, JAPAN; Akira Yajima, Ebina, JAPAN;				
<b>** CONTINUING DATA *****</b>  <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2000-284374 09/19/2000 LC				
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 04/30/2001</b>				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 118 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance LC Verified and Acknowledged		STATE OR COUNTRY JAPAN	SHEETS DRAWING 19	TOTAL CLAIMS 16
		INDEPENDENT CLAIMS 3		
<b>ADDRESS</b> 020457				
<b>TITLE</b> Semiconductor device and method for manufacturing the same and semiconductor device-mounted structure				
<b>FILING FEE RECEIVED</b> 1200	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	